

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAGAHAMA et al

Serial No. 09/500,288

Filed: February 8, 2000

For: NITRIDE SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD



Atty. Ref.: 925-179

Group: 2824

Examiner: Wilson

\* \* \* \* \*

May 22, 2001

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**INFORMATION DISCLOSURE STATEMENT**

Attention is invited to the attached documents which may be of relevance during the examination of this application. A completed Form PTO-1449 is also attached.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO-1449 with the examiner's initials in the left column [MPEP §609] with the next communication.

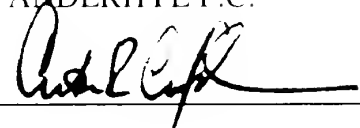
The filing of an Information Disclosure Statement shall not be construed as a representation that a search has been made [37 C.F.R. § 1.97(g)], an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists. Further, the filing of an Information Disclosure Statement shall not be construed as an admission against interest in any manner [Commissioner's Notice of January 9, 1992, 1135 O.G. 12-25 at 25].

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Respectfully submitted,

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